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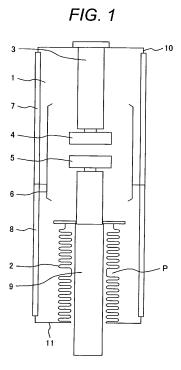
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## (54) VACUUM VALVE AND SWITCHGEAR EQUIPPED WITH SAID VACUUM VALVE

(57) The object of the present invention is to provide a vacuum valve with strength against buckling deformation and without pressure leakage.

A vacuum valve 1 comprising a fixed electrode 4 and a movable electrode 5 facing each other; a vacuum container containing the fixed electrode and the movable electrode and the interior thereof being in a vacuum state; and a bellows 2 forming a border between the inside and the outside of the vacuum container, for enabling the connecting and disconnecting movement of the movable electrode 5 using an elastic force generated by a plurality of pleated structure while maintaining the vacuum pressure inside the container, wherein the bellows 2 has a region without pleats or a region with low pleats.



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